

# Results from a multi-metallic conduction-cooled SRF single-cell cavity

Tesla Technology Collaboration Meeting

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CERN

arXiv:2001.10924 [physics.ins-det]

R. Rimmer

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Jefferson Lab



Left to right: K. Harding, J. Henry, D. Tucker, R. Rimmer, G. Ciovati and G. Cheng. Not shown: U. Pudasaini



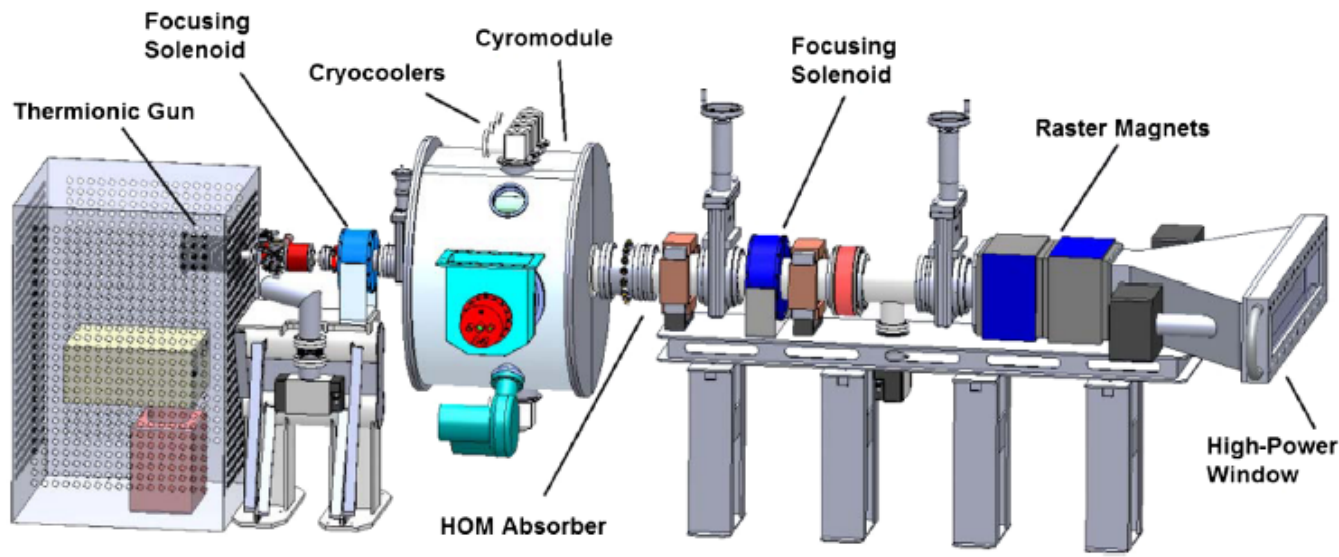
U.S. DEPARTMENT OF  
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Science



# Objective

- Demonstrate operation of a single-cell SRF cavity by conduction cooling using a commercial cryocooler
  - Use  $\text{Nb}_3\text{Sn}$  thin film to achieve lower  $R_s$  than Nb at  $T > 4$  K
  - Deposit thick Cu outer shell for good thermal conduction
  - Minimize number of joints between the 4 K stage of cryocooler and the cavity



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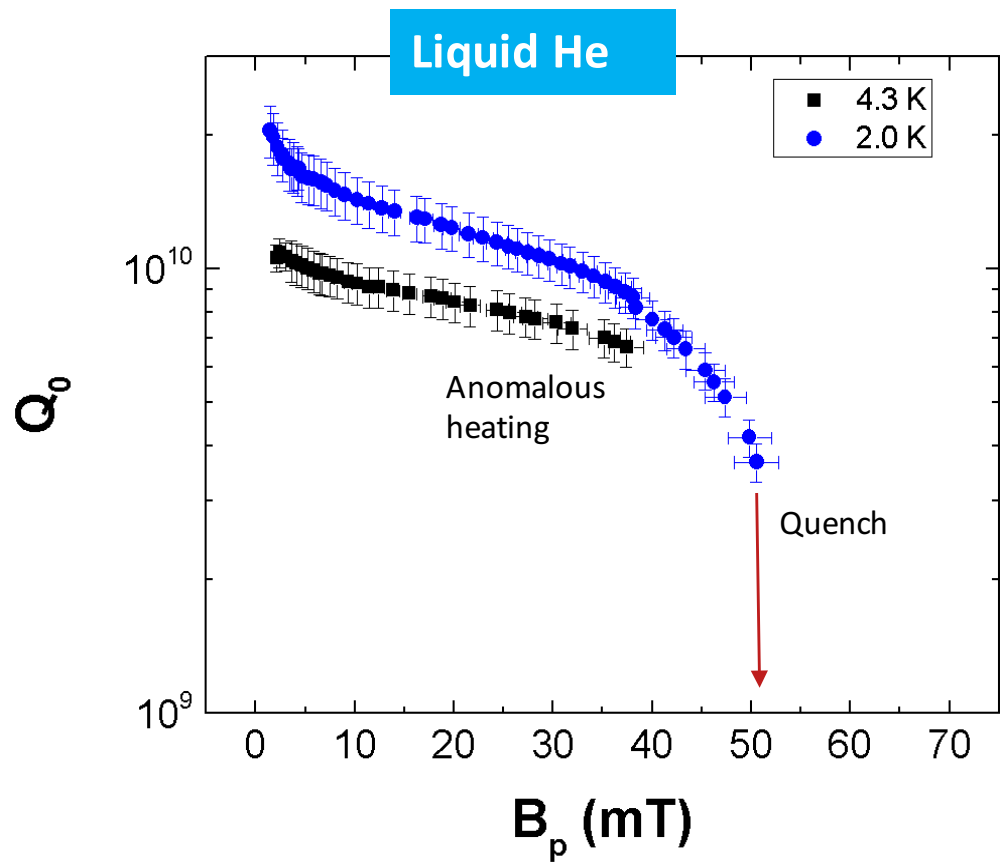
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# Nb<sub>3</sub>Sn coating

- Nb<sub>3</sub>Sn thin film grown by vapor diffusion at 1200 °C on ~2.9 mm thick bulk Nb (large grain) 1.495 GHz single cell cavity
- Synergy with Nb<sub>3</sub>Sn development program at JLab



Courtesy of G. Ereemeev



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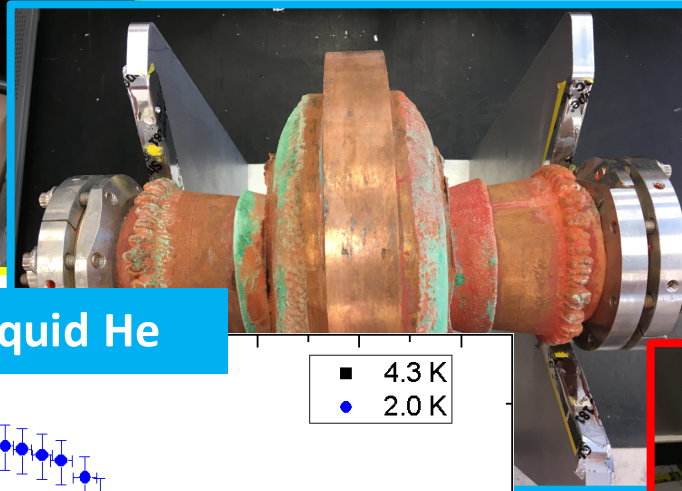
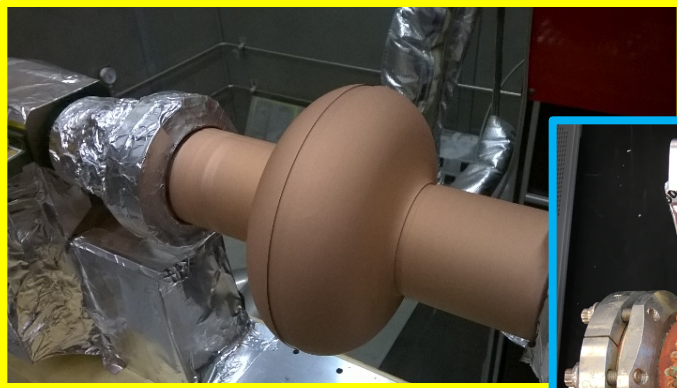
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# Cu outer coating (1)

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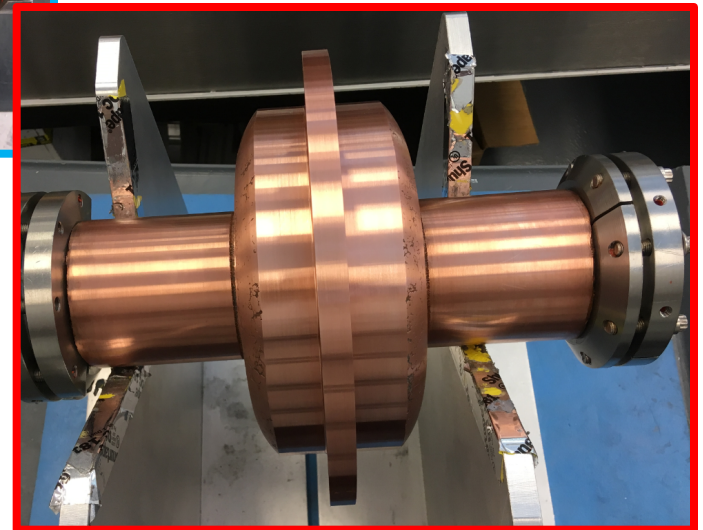
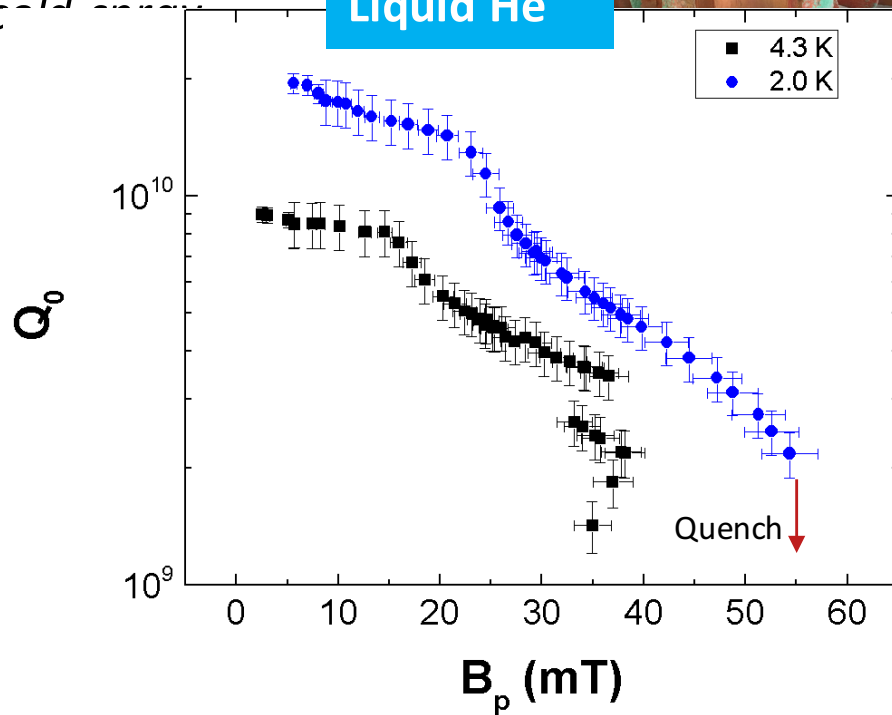
- Thermal analysis with ANSYS indicated  $\geq 5$  mm thick Cu outer layer to allow reaching  $\sim 37$  mT with conduction cooling
- Deposit seed layer ( $\sim 76$   $\mu\text{m}$  thick) of Cu on Nb outer surface by cold-spray at CTC, Johnstown, PA
- Deposit  $\geq 5$  mm thick oxygen-free Cu on seed layer by electroplating at AJ Tuck Co., Brookfield, CT. A 10" diameter,  $\frac{1}{2}$ " thick ring was also grown at the equator by electroplating.
- Thermal conductivity measurement on Nb/Cu samples showed  $\sim 1000$  W/(m K) at 4.3 K

# Cu outer coating (2)



Liquid He

After cold



After machining

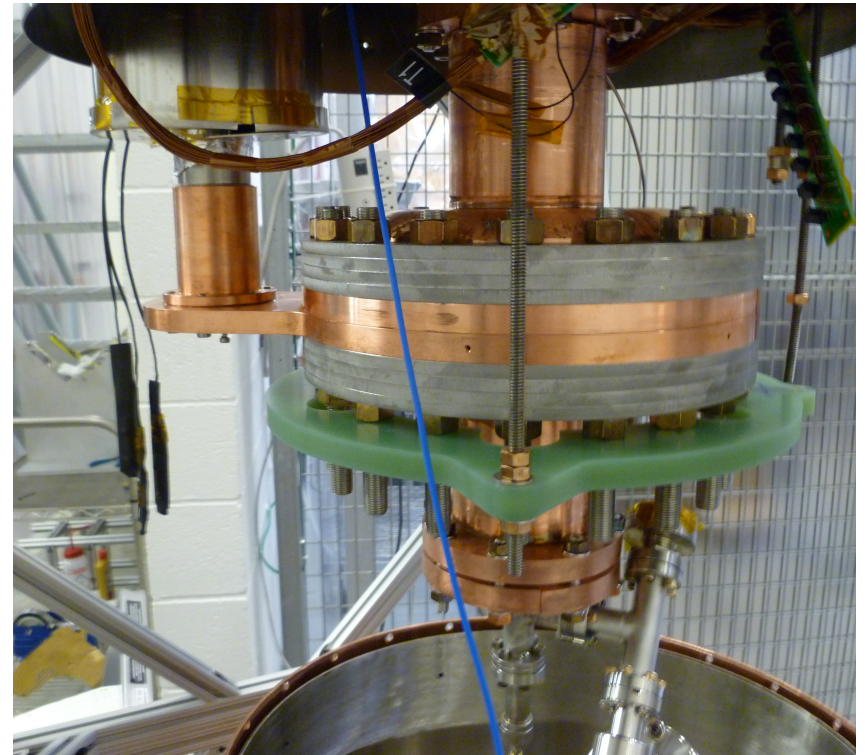
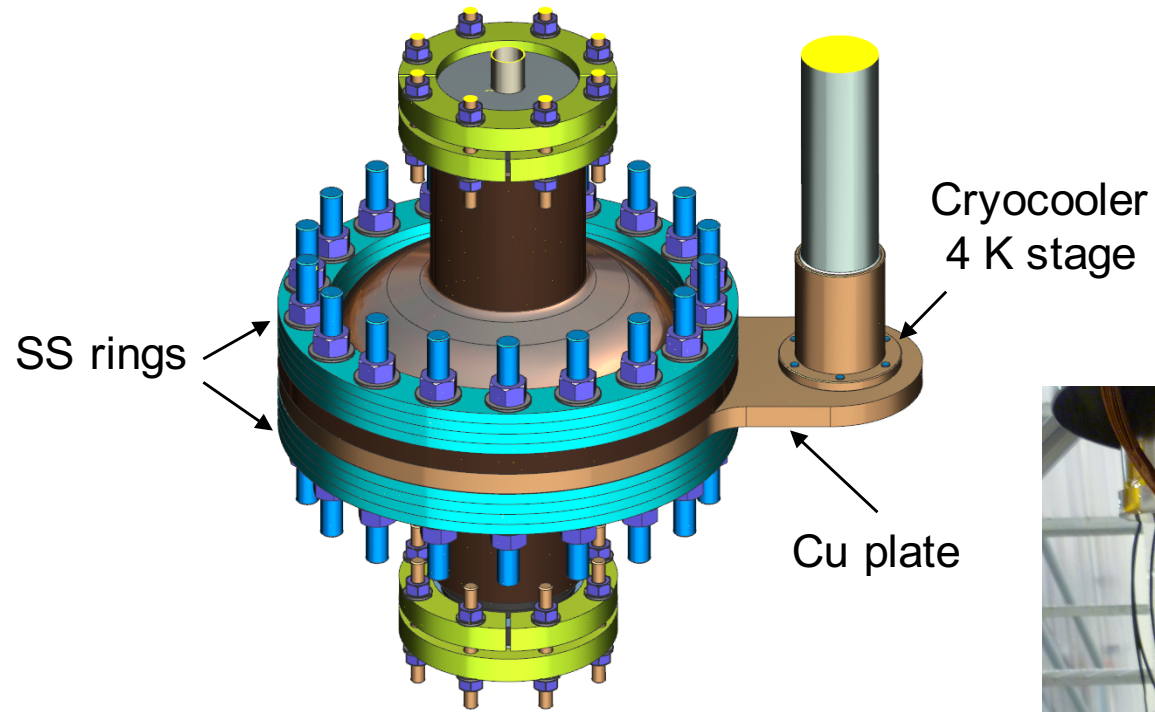
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# Cryocooler connection



**Cryocooler:** Gifford-McMahon type,  
Sumitomo RDE-418D4, cooling power:  
2 W at 4 K

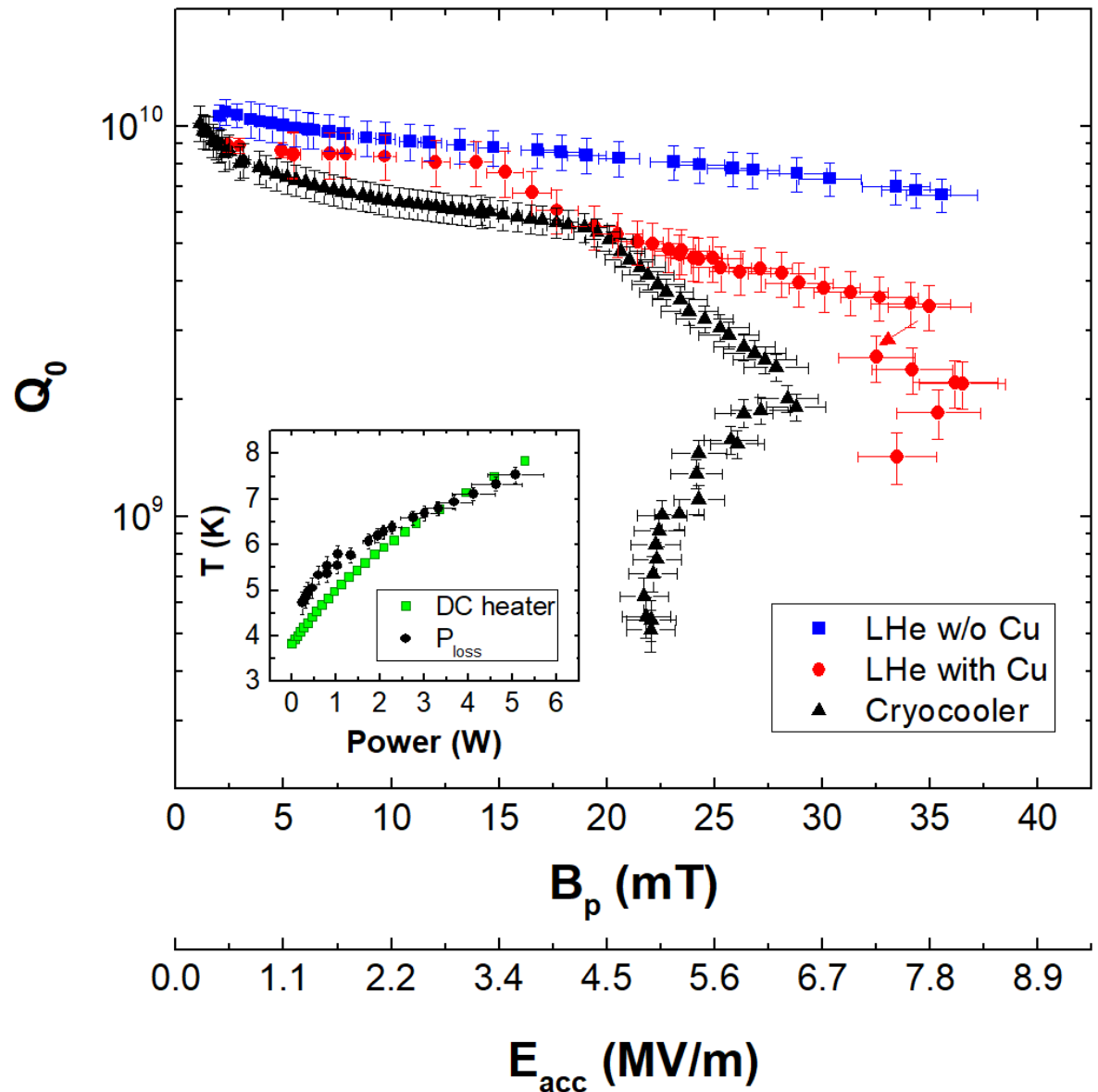
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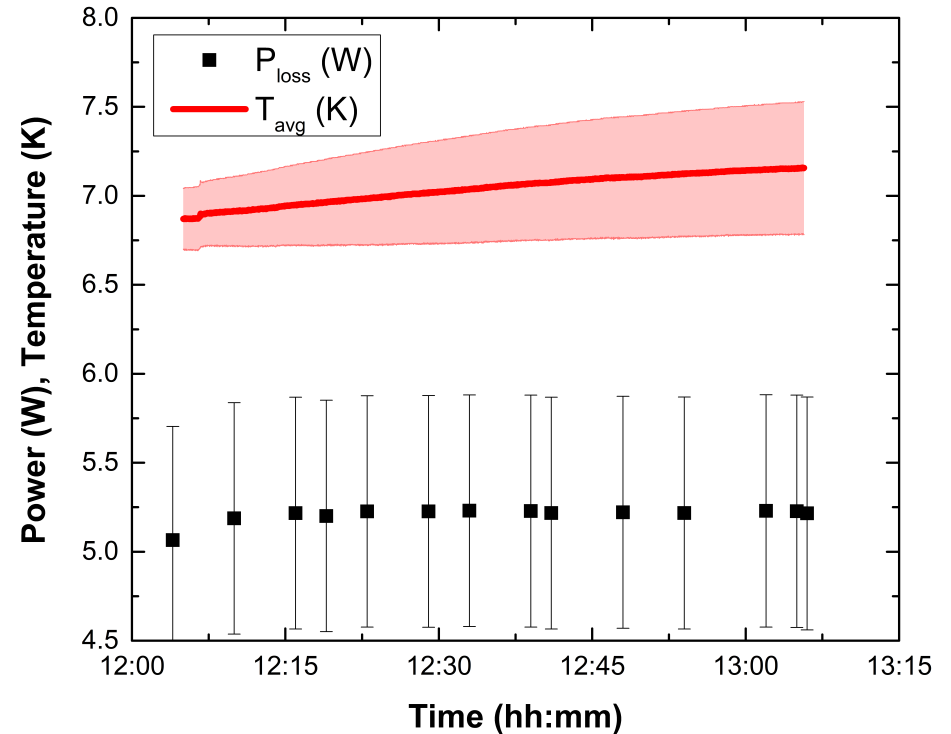
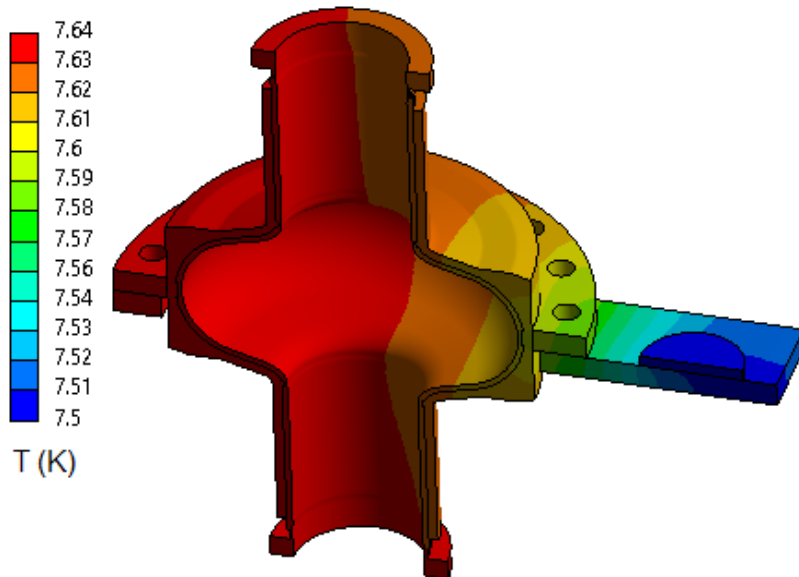
# RF test results

- Cavity temperature after cooldown:  $\sim 3.8$  K
- T-gradient at 18 K:  $\sim 0.09$  K/cm
- Max residual B at 18 K:  $\sim 14$  mG
- Amplitude of microphonics: 13.8 Hz pk-to-pk



# RF test results

- The cavity was thermally stable during a 1 h operation at  $P_{\text{diss}} = 5 \text{ W}$  even with anomalous losses ( $Q_0 \sim 5e8$  at 22 mT)



- Cu layer allows remarkable thermal stability

# Conclusions

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- We developed for the first time a multi-metallic Cu/Nb/Nb<sub>3</sub>Sn single-cell cavity
- We were able to demonstrate operation of the cavity up to  $B_p \sim 29$  mT ( $E_{acc} \sim 6.5$  MV/m), limited by defects in the Nb<sub>3</sub>Sn film
- The cavity exhibited remarkable thermal stability even with 5 W of power dissipation
- The amplitude of microphonics was well within what has been measured in standard cavities in cryomodules
- **These results are a stepping stone towards developing SRF industrial accelerators**

# Acknowledgments

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- B. Golesich at CTC, A. Tuck at AJ Tuck Co.
- JLab cavity production group and machine shop
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- M. Dale at Sumitomo Cryogenics of America